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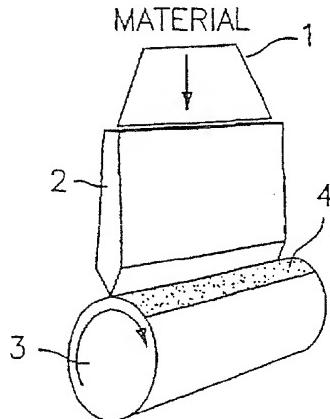
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### (54) Embossing surface and embossing process using photo definable polyimide film

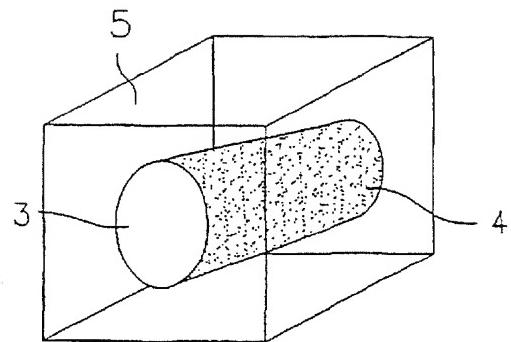
(57) An embossing surface (4) and a method for creating that surface (4) is provided by a polyimide material (1) which has photodefinable characteristics. One benefit is that the embossing surfaces (4) do not have to be made by data transfer from the photodefinable surface. The polyimide material is cured by heating (5,7) to a predetermined hardness appropriate for the surfaces to be embossed.



COATING ROLLER

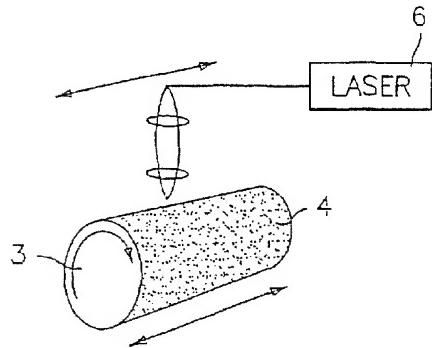
FIG. 1(a)

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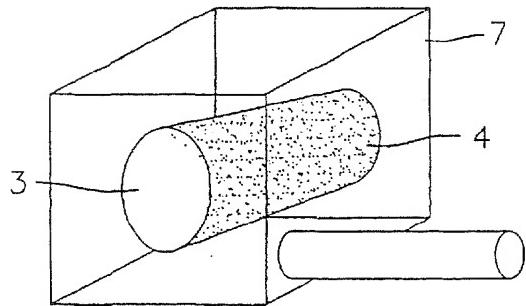
PRE-CURE

*FIG. 1(b)*



DIRECT WRITE DOT MATRIX

*FIG. 1(c)*



HARDING POST CURE

*FIG. 1(d)*

**Description**

[0001] The present invention relates generally to the field of embossing photo-profiled data. In particular, the present invention is directed to a material and a method for using the subject material to eliminate steps between photo-profiling and embossing.

[0002] Embossing tools are used in a wide variety of applications for transferring data from one medium to another. One example is the mass production of holograms, using embossing tools, for the holographic portions of credit cards. Holograms are also created for a large number of other products, including periodical advertising, wrapping paper and other decorations, a wide range security devices, packaging, and artwork. Mass production of such holograms is carried out by impressing a film with an embossing die containing the holographic relief pattern.

[0003] The embossing die or tool is the key feature of this process, and requires a high degree of precision in its manufacturing in order to successfully generate large quantities of high quality holograms. Conventionally, such tools are produced using a number of steps. The first step involves a photoresisted plate exposed to a holographic interference pattern used to form the "master" hologram. After exposure to the holographic light pattern, the photoresist is developed to form a surface-relief pattern in the photoresist corresponding to the holographic interference pattern.

[0004] Then a thin layer of nickel is electroformed onto the relief surface of the photoresist to transfer the interference pattern. The nickel layer is then peeled away from the photoresist. This nickel layer becomes the master, and a second nickel layer is made as a copy of the first. The second nickel layer serves as the stamper, and is clamped to a substrate, either by being wrapped around a cylinder or being held to a flat plate which forms a die. Each of the layers is known as a shim. Generally there are two shims used, with one being kept aside as a master while the other is used as a stamper. The metal die is then used to stamp or press a transparent film, impressing the holographic interference pattern onto the film, thereby creating the production holograms. This process is used for a wide variety of different types of holograms, including those constituted by translucent films viewed with laser light, defraction patterns, "2D" & "3D" holograms, and virtually any other holographic pattern that lends itself to mass production.

[0005] Unfortunately, there are certain limitations to such conventional techniques. For example, nickel is the preferred metal for creating an embossing tool to transfer the holographic interference pattern. Accordingly, only material softer than nickel can be imprinted by the die. For example, nickel can be used for imprinting on polyester films, soft plastics and the like. However, even with such soft material nickel deforms after continuous use so that after a few thousand meters of embossing, the embossing tool deteriorates to the point

that it is no longer suitable for turning out copies.

[0006] Also, when a die is wrapped around a printing cylinder or roller, a seam runs approximately parallel to the axis of the cylinder. For the sake of accuracy, the 5 holographic pattern cannot be located anywhere near the seam. In particularly large printing cylinders, multiple shims are used since it is often very difficult to make shims large enough for some embossing rollers. The chief problem with this situation is that there is a mark in the material every time that this seam comes around as a result of the rotation of the roller. As a result, a good deal of the roller surface is lost for practical use, and the size of the hologram that can be printed is severely limited. Since it is very difficult to make a solid cylindrical 10 roller by a metal deposition process, such as electroplating, this problem probably cannot be solved using conventional techniques, which are not adaptable to creating a seamless roller.

[0007] Other, harder materials have been tried in the 20 production of embossing tools. For example, aluminum has been used for embossing dies for holographic transfer. However, the process for making the aluminum die is severely limited by the chemical etching process so that accuracy of the etched pattern degrades rapidly 25 with increasing depth of the etching. Also, aluminum is not a particularly good material for extremely high pressures, such as those used in creating embossed holograms.

[0008] Other, harder materials have been used. For 30 example ion milling or etching has been used to create holographic patterns on such materials as tool steel, diamond or chromium. One example of such a technique is found in U.S.-A-5,521,030. This patent discloses the use of anisotropic reactiveion etching to transfer a holographic interference pattern from a photoresist to the durable material to be used as an embossing tool.

[0009] Unfortunately, such techniques for forming holographic interference patterns on durable materials are 35 extremely expensive and complex to carry out. Such techniques are only justified when large numbers of accurate holograms have to be embossed. Otherwise, the expense of such techniques can not be justified.

[0010] Further, none of the conventional techniques are capable of providing for seamless embossing, or 40 any of the advantages associated therewith. Accordingly, there is still a need to inexpensively create embossing tools on hard material that can be used to transfer holographic interference patterns under conditions of high pressure without degrading the resultant copies, even 45 for extended production runs.

[0011] According to this invention an embossing surface is configured for transferring data to other surfaces, where the embossing surface consists of a photodefined polyimide material.

[0012] A second embodiment of the present invention 50 is manifested by a method of embossing data from an embossing surface to other surfaces. The method consists of the steps of exposing a photodefinition material

to EM radiation defining the data. Afterwards, the photodefinable material is cured to achieve an embossing surface of a selected hardness. Finally, the embossing surface is used to emboss the data onto other surfaces. [0013] Particular embodiments in accordance with this invention will now be described with reference to the accompanying drawings; in which:-

Figure 1(a) is a perspective view depicting the transfer of polyimide material onto an embossing roller;

Figure 1(b) is a perspective diagram depicting the precuring phase of the polyimide material;

Figure 1(c) is a perspective diagram depicting the photo defining of the polyimide material on the roller; and,

Figure 1(d) is a perspective diagram depicting the hardening phase prior to embossing.

[0014] The present invention includes the use of a photodefinable or photoprofileable, positive-acting (positive tone) polyimide as an embossing surface. The polyimide is treated as depicted in Figures 1(a) - 1(d), and as described *infra* for the purpose of the present invention. The polyimide material is placed on an appropriate surface, heat-treated, exposed to EM radiation (such as coherent light) and hardened into an embossing surface. Then the embossing surface is used to transfer data expressed as the EM radiation to another surface. This technique for using polyimide material is particularly effective for creating a holographic master to be used as an embossing surface.

[0015] Because of the characteristics of the polyimide material, it is also suitable for use as a gravure printing surface. Such a surface is created by first exposing the surface to EM radiation and a flash application of metal to provide a printing surface. The positive photoresist characteristics of the polyimide material make this second embossing embodiment possible without the complications of conventional gravure printing processes, such as etching.

[0016] The polyimide material could be coated on virtually any surface, profiled, and then hardened to be used as a decorative or display surface. The use of such materials provides an advantage for artists since no material currently exists that can be easily formed, while still withstanding cleaning and ultraviolet radiation. Accordingly, the subject polyimide material can be used on any surface that could withstand the necessary curing temperatures.

[0017] The polyimide material can also be used in a casting operation to transfer the grooves of an existing hologram onto the polyimide material. Then, the pattern from the cast polyimide can be applied to other surfaces. Virtually any kind of casting technique can be used with the polyimide material, examples of which are described *infra*.

[0018] The polyimides, which are applied to the novel

uses in the instant application, are high temperature engineering polymers originally developed by the DuPont Company. When compared to most other organic or polymeric materials, polyimides exhibit an exceptional combination of thermal stability (>500°C), mechanical toughness and chemical resistance. In addition, they have excellent dielectric properties.

[0019] Conventionally polyimide films are frequently used as a "stress buffer" or protective overcoat for semiconductors. Polyimide stress buffers are typically 4-6 microns in thickness, and protect the delicate thin films of metal and oxides on the chip surface from damage during handling and from induced stress after encapsulation in plastic molding compound.

[0020] When used as a photo-definable material, patterning is simple and straightforward. Because of the low defect density and robust plasma etch resistance inherent with polyimide films, a "single mask" process can be implemented.

[0021] In the conventional fabrication of microelectronic devices, photodefinable polyimides are typically applied as a liquid onto a substrate, and then thermally cured into a smooth, rigid, intractable polymeric film or structural layer as further described, *infra*. The film can be patterned using a lithographic (photographic) process in conjunction with liquid photoresists. "Photodefinable" polyimides are light-sensitive and readily patterned without the use of photoresists, further simplifying the fabrication process.

[0022] For purposes of demonstrating the effectiveness of the present invention, the photodefinable, positive-acting polyimide selected is HD-8000, a product of HD Microsystems™, a joint enterprise between Hitachi Chemicals and DuPont Electronics. IHD-8000 is a positive-tone, aqueous developing, photodefinable polyimide for stress buffer and chip bonding applications. I-HD-8000 includes a polyamic acid back-boned precursor that is synthesized by reacting aromatic dianhydrides with aromatic diamines. Also included are photosensitizers to provide positive tone lithographic properties during processing. Solvents are included as well. This material achieves pattern definition which greatly exceeds that of earlier-generation aqueous developing products.

[0023] The aforementioned polyimide material is positive tone or positive acting and can be developed with an aqueous solution. However, this merely one example of the type of polyimide material that can be used with the present invention. For example, a negative tone or negative acting polyimide can also be used depending upon the exact implementation of data transfer to which the material will be put. Also, the polyimide material that is developed with nonaqueous solutions can also be used for purposes of the present invention.

[0024] In Figure 1(a) the polyimide material is arranged using an applicator 2 on the moveable surface such as coating roller 3. The application of the polyimide material forms a coating 4 on the roller. It should be noted

ed that while a roller is used in the example of Figure 1 (a), other surfaces can also be used for the application of polyimide material for photo defining and later embossing operations.

[0025] In most microelectronic applications polyimide coatings are typically spin applied to the substrate. This same process and basic tool set is also used to apply liquid photoresists. For optimal adhesion to silicon, oxides and most metals, adhesion promoters are required. Some polyimides have built in adhesion promoters, while others require the application of a separate adhesion promoter or coupler prior to polyimide application. Adhesion promoters are also applied by spin coating.

[0026] While spin coating assures the best uniformity and coating quality, other application techniques that have been used for applying polyimides include draw, spray, extrusion, roller, dip and drop coating.

[0027] While a rotating cylinder 3 has been used for coating 4, other shapes of embossing surfaces can also be used. For example, a flat surface can be used with a platen moved in two directions, or even a platen that moves in one direction while the source of EM radiation is also moving in one or more directions.

[0028] It should be noted that the data to be transferred by means of the present invention can be expressed in a wide variety of different configurations. For example, holograms are of particular interest, and the transfer of holograms is easily facilitated by the present invention. Such holograms can include translucent films viewed with laser light, defraction patterns, "2D" "3D" stereograms, true "3D" holograms, as well as virtually any other holographic format for arrangement can be transferred using the present invention. It should be further noted that the present invention is not limited to the transfer of holographic material. Rather, virtually any other type of data that can be transferred by means of embossing can be quickly and accurately transferred using the system of the present invention.

[0029] In Figure 1(b), the roller 3 with its polyimide coating 4 is placed in a curing oven 5. In the alternative, the coated substrate could be heated or soft baked on hot plates at 120°C for approximately 130-260 seconds. This is done for a target fixed thickness of 10 microns. However, different target thicknesses will require different baking times. After the pre-cure operation has altered the polyimide material 4 to a predetermined thickness and consistency, the polyimide material is ready for alteration or profiling by electromagnetic radiation, such as light.

[0030] Coated substrates should be cooled to ambient temperature prior to EM exposure. A chill plate is recommended for cooling after the heat treatment. For improved control, the wafers should be held for a minimum of 20 minutes prior to exposure. The coated substrates can be stored for up to 72 hours in a wafer cassette box under clean room conditions prior to exposure and development. In Figure 1(c) the light is monochromatic and provided by laser 6. It should be noted that

while one preferred embodiment as depicted in Figure 1(c), uses a laser light source, other forms of electromagnetic radiation can be used. Examples are light having plural frequency elements, x-rays, radio waves, ultraviolet light, electron beams and infrared light. Photo-sensitive polyimides permit the patterning of relatively fine features. An aspect ratio of 1 to 1 can be achieved in fully cured films.

[0031] Data (from a source not shown) is expressed by the light from laser 6, and is used to profile or otherwise define or modify the polyimide coating 4 on roller 3. On example of such a photo defining technique is the pixel-by-pixel method disclosed in U.S.-A-5,822,092.

[0032] Part of the light profiling of the polyimide material 4 is the development of the material that has been exposed or otherwise profiled by the incident electromagnetic radiation, such as coherent light. In the preferred embodiment depicted in Figures 1(a)-1(d), a well-known type of aqueous solution is used to develop the exposed polyimide material. This can be carried out using a number of different techniques. For example, the entire roller 3 can be submerged in a bath (not shown). In the alternative, a developing chamber (not shown), similar to the heat treatment chambers, can be used to apply the developing solution. However, any other technique used for developing, using either aqueous or non-aqueous developing solutions are also suitable for the present invention. Any known combination of radiation exposure and development effective for any polyimide is suitable for the Figure 1 (c) operation of photoprofiling of the polyimide material.

[0033] After being profiled by the light from laser 6, and developed, the polyimide coating 4, arranged on roller 3 is heat-cured, for example in another oven 7. The curing takes place according to the parameters specified in the Preliminary Product Bulletin by HD MicrosystemsTM, entitled *Photo Definable Image HD8000 Series Positive Tone, Aqueous Developable Polyimide*.

[0034] Curing the polyimide film involves the removal of the solvent carrier or other volatiles from the layer and the imidization or hardening of the polymer into an intractable polyimide film. This curing process is typically done in steps. Hot plates are commonly used for the initial heat treatment or bake (Figure 1(b)) after the polyimide application. The initial application can range from 50°C to 150°C on one or more in-line hot plates. A furnace or programmable oven is used for the final cure (Figure 1(d)). Final curing is usually done between 280°C - 400°C depending on the application.

[0035] The objectives of a proper cure schedule are to: 1) remove residual solvents, 2) complete the imidization process, 3) complete the adhesion process. Because all three of these actions can occur simultaneously at a given temperature, the cure schedule is a very important process step which can impact cured film quality and associated mechanical properties.

[0036] The following variables need to be considered in curing polyimide films:

curing tool; atmosphere; loading temperature; ramp rate; soaks (holding temperatures); final cure temperature; and, ramp down.

[0037] Curing is typically done as a batch process using programmable ovens or furnaces. (Single-wafer curing tools that utilize a series of hot plates have also been developed for in-line processing. This technique has been frequently used with non-photo-definable polyimides.)

[0038] Curing should be performed under a nitrogen atmosphere (oxygen conc. <100ppm). Some programmable ovens are designed to cure under a vacuum. A partial vacuum may be used with a nitrogen atmosphere.

[0039] Loading temperatures, ramp rate, soaks (intermediate holding temperatures), final cure temperature and cool down rate can be optimized for optimum throughput and cured film properties. A basic cure schedule is given for a typical "single-mask" stress buffer application : load into oven or furnace at <150°C; ramp from loading temperature to 350°C over a 60 minute period; hold at 350°C for 30 minutes; and, substrates can be unloaded immediately or allowed to cool down. It should be noted that the curing can also be done in an oven without the special atmosphere. The selection of oven atmosphere depends upon a number of factors, such as the size of the area of the polyimide to be cured, the thickness of the final polyimide coating, and the other curing factors.

[0040] While one type of polyimide has been described, and proven to work, this is merely one example of the various photo-definable, polyimide materials that can be used to constitute the embossing system of the present invention. Further, such materials are particularly appropriate for transferring dot matrix holograms.

[0041] Based upon the aforementioned specification, the polyimide can be cured to a predetermined hardness and thickness on roller 3. Because the polyimide material forming layer 4 can be cured to a predetermined hardness, it is possible to use the polyimide surface 4 as an embossing surface. Consequently, the formation of a conventional metal embossing surface for transferring holograms is not necessary with the present invention. The result is a substantial saving of time and expense. Because the polyimide used in the preferred embodiment can be used as a positive exposure substance, the material can also be used for gravure printing, in which the printed material is formed as depressions around unprofiled photoresist material. The ink is placed within the grooves that constitute the letters or the images, and the paper or other transfer surface is forced on the profiled surface so that the ink in the depressions is forced onto the transfer surface. The polyimide material is capable of being cured to a consistency that will handle the pressure handled for gravure printing operations. It should be noted that the roller 3 depicted in the drawings need not be used in this printing process.

Rather, a flat platen can be used in the alternative. However, it should be noted that most printing takes place in roll presses so that roller 3 would most likely be the preferred surface for this type of system.

5 [0042] The use of polyimide for gravure printing requires a flash coating of a metal, such as nickel or chrome to be placed on the polyimide coating. However, the acid wash that is used in more conventional photo-defining preparatory to gravure printing, is not necessary.

10 As a result, the acid used in such washes will not degrade the metal defining the data to be transferred. Accordingly, the present invention avoids the loss of clarity or accuracy, as well as size limitations, inherent to conventional gravure printing systems. Accordingly, gravure printing using the polyimide in accordance with the present invention is carried out more easily and more cheaply than conventional systems, and results in a better product.

15 [0043] The polyimide material can be used in another embodiment to copy the interference pattern of a hologram, or any other data in a relief pattern. This is done by forming a casting of the polyimide material over a holographic master. As a result, an impression of the diffraction grating pattern is made on the casting material. The casting is then used to transfer the data from the holographic master to other surfaces. In so doing, the benefits previously described with respect to the polyimide material are achieved for copies made from the polyimide casting.

20 [0044] Particular aspects of the invention will now be described in the following numbered clauses:-

30 1. An embossing surface configured for transferring data to other surfaces, said embossing surface consisting of a photodefined polyimide material.

35 2. The embossing surface of clause 1, wherein said polyimide is aqueous developable.

40 3. The embossing surface of clause 2, wherein said data is transferred to said embossing surface by photo detection.

45 4. The embossing surface of clause 3, wherein said data is text.

50 5. The embossing surface of clause 3, wherein said data is image data.

55 6. The embossing surface of clause 3, wherein said polyimide is hardened by baking.

7. The embossing surface of clause 3, wherein said polyimide is defined to be positive tone.

8. The embossing surface of clause 7, further comprising a flash-coated metal film over said polyimide.

9. The embossing surface of clause 8, wherein said embossing surface is suitable for gravure printing.

10. A method of embossing data from an embossing surface to other surfaces, said method consisting of the steps of:

(a) exposing a photo-definable material to EMF

- radiation defining said data;
- (b) curing said photo-definable material to achieve an embossing surface of a selected hardness; and,
- (c) using said embossing surface to emboss said data onto said other surfaces.
11. The method of clause 10, wherein step (a) comprises a subsequent substep of:
- (i) developing said photo-definable material with a solvent.
12. A method of clause 11, wherein step (a), further comprises a preliminary substep of:
- (ii) applying said photo-definable material to a roller.
13. The method of clause 12, wherein step (a) further comprises a preliminary substep of:
- (iii) pre-curing said photo-definable material by heating.
14. The method of clause 10, wherein said photo-definable material is a polyimide.
15. The method of clause 10, wherein said step (c) of curing comprises heating said photo-definable material.
16. The method of clause 10, wherein said EMF radiation comprises light.
17. The method of clause 16, wherein said light is monochromatic and generated by a laser.
18. The method of clause 15, wherein step (c) comprises a preliminary substep of:
- (ii) applying a coating of metal over said polyimide material.
19. The method of clause 18, wherein said step (c) of using said embossing surface to emboss said data is carried out as gravure printing on said other surfaces.
20. The method of clause 19, where the photo-definable material is copied by electroforming using nickel.
21. The method of clause 19, wherein said photo-definable material is copied by electroforming using chrome.
22. The method of clause 10, wherein said data is selected from a group consisting of images, printed text, reliefs and holograms.
23. The method of clause 22, wherein said data is in a holographic dot matrix format.
24. The method of clause 10, wherein said photo-definable material is applied to a flat surface.
25. The method of clause 10, wherein said photo-
- definable material is applied as an embellishment coating to an object.
26. A method of transferring data from a first surface to other surfaces to a transfer medium, said method consisting of the steps of:
- (a) casting said transfer medium on a surface containing said data; and, (b) using said transfer medium to emboss said other surfaces.
27. The method of clause 26, wherein said transfer medium is polyimide.
- 15 Claims**
1. An embossing surface configured for transferring data to other surfaces, said embossing surface consisting of a photodefined polyimide material.
  2. An embossing surface according to claim 1, wherein said polyimide is aqueous developable material.
  3. An embossing surface according to claim 1 or 2, wherein said data is transferred to said embossing surface by exposing said surface to EM radiation.
  4. An embossing surface according to any one of the preceding claims, further comprising a flash-coated metal film over said polyimide.
  5. An embossing surface according to claim 4, wherein said embossing surface is suitable for use as gravure printing form.
  6. A method of embossing data from an embossing surface to other surfaces, said method consisting of the steps of:
    - (a) exposing a photo-definable material to EM radiation defining said data;
    - (b) curing said photo-definable material to achieve an embossing surface of a selected hardness; and,
    - (c) using said embossing surface to emboss said data onto said other surfaces.
  7. A method of claim 6, wherein step (a) comprises a subsequent substep of:
    - (i) developing said photo-definable material with a solvent.
  8. A method according to claim 6 or 7, wherein said EM radiation is light, is monochromatic and is generated by a laser.
  9. A method of according to claim 8, wherein said data

is in a holographic dot matrix format.

10. A method of transferring data from a first surface to other surfaces to a transfer medium, said method consisting of the steps of:

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(a) casting said transfer medium on a surface containing said data; and, (b) using said transfer medium to emboss said other surfaces.

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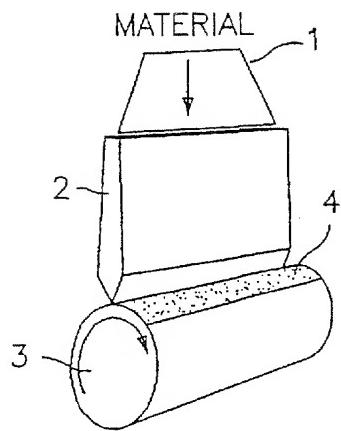
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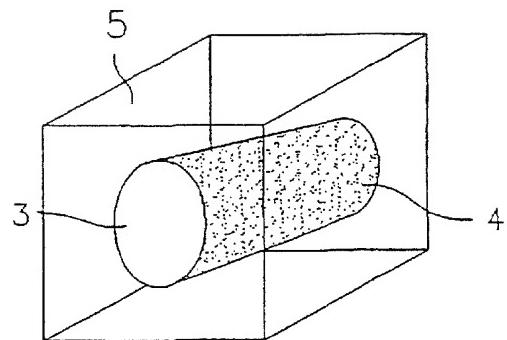
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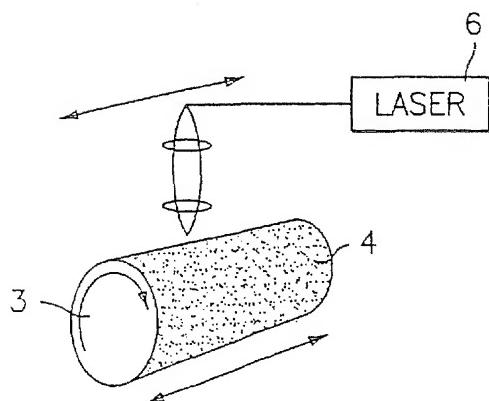
COATING ROLLER

*FIG. 1(a)*



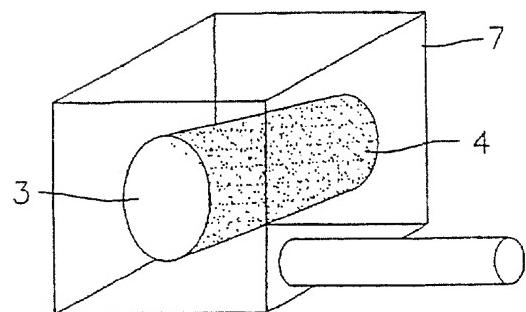
PRE-CURE

*FIG. 1(b)*



DIRECT WRITE DOT MATRIX

*FIG. 1(c)*



HARDING POST CURE

*FIG. 1(d)*

